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From: Jacqueline J. Garner
Texas Instruments Incorporated
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: DeLoach et al. Art Unit: 2822
Serial No.: 10/703,387 Examiner: Thomas, T.
Filing Date: 11/06/2003 Docket No.: TI-35862
Customer No.: 23494 Conf. No.: 9996
Title: FORMING A TRENCH TO DEFINE ONE OR MORE ISOLATION
REGIONS IN A SEMICONDUCTOR STRUCTURE

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date shown below:


Jacqueline J. Garner, Reg. No. 36,144January 3, 2005
Date

FACSIMILE COVER SHEET

<input checked="" type="checkbox"/> FACSIMILE COVER SHEET	<input checked="" type="checkbox"/> AMENDMENT (7 Pages)
<input type="checkbox"/> NEW APPLICATION	<input checked="" type="checkbox"/> EOT 3mth (3 Pages)
<input type="checkbox"/> DECLARATION (# Pages)	<input type="checkbox"/> NOTICE OF APPEAL (# Pages)
<input type="checkbox"/> ASSIGNMENT (# Pages)	<input type="checkbox"/> APPEAL (# Pages)
<input type="checkbox"/> FORMAL DRAWINGS	<input type="checkbox"/> ISSUE FEE (# Pages)
<input type="checkbox"/> INFORMAL DRAWINGS	<input type="checkbox"/> REPLY BRIEF (IN TRIPLICATE) (# Pages)
<input type="checkbox"/> CONTINUATION APP'N (# Pages)	
<input type="checkbox"/> DIVISIONAL APP'N	
NAME OF INVENTOR(S): De Loach	
TITLE OF INVENTION: Forming a Trench . . .	
TI FILE NO.: TI-35862	DEPOSIT ACCT. NO.: 20-0668
FAXED: 1/3/2005 DUE: JJG ATTY/SECY: JJG	
RECEIPT DATE & SERIAL NO.: Serial No.: 10/703,387 Filing Date: 11/06/2003 Conf. No.: 9996	

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Texas Instruments Incorporated
PO Box 655474, M/S 3999
Dallas, TX 75074

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AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Jacqueline J. Garner
Reg. No. 36,144

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated 7/1/2004. They are respectfully submitted as a full and complete response to that Action.

Please amend the above-referenced application as follows:

There are no **Amendments to the Specification.**

Amendments to the Claims are reflected in the listing of claims that begin on page 2 of this paper.

There are no **Amendments to the Drawings.**

The **Remarks** begin on page 7.